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PATENT

IN THE UNITED STATES DESIGNATED OFFICE (DO/US)

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INTERNATIONAL APPLICATION NO.

26 July 2004 (26.07.2004)

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25 July 2003 (25.07.2003)

PRIORITY DATE CLAIMED

TITLE OF INVENTION

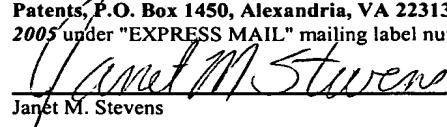
SEMICONDUCTOR ELEMENTS HAVING ZONES OF REDUCED OXYGEN

APPLICANT(S) FOR DO/US

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Mail Stop PCT
Attention: DO/US
Commissioner for Patents
P.O. Box 1450
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Janet M. Stevens

PRELIMINARY AMENDMENT

Sir:

Prior to examination, please amend the subject application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.